



5.C5745 CIP

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
SEISHIRO YOSHIOKA ET AL.)
Serial No.: 07/705,720)
Filed: May 24, 1991)
For: ELECTRON-EMITTING DEVICE) January 27, 1993

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The Honorable Commissioner of Patents
and Trademarks
Washington, D.C. 20231

REQUEST FOR APPROVAL TO MAKE DRAWING CORRECTIONS

Sir:

In response to the Official Action dated July 27, 1992, Applicants hereby request approval to make the following drawing corrections:

In Figure 39B and Figure 39C, please identify the line upon which the glass substrate (S) is attached, as "VC" (vacuum container) as shown on the attached photocopies in red-ink of these figures.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231 on January 27, 1993

(Date of Deposit)

PENINA WOLLMAN

(Name of Attorney for Applicant)

Penina Wollman
Signature

January 27, 1993
Date of Signature

This request is submitted in duplicate.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 758-2400 or by facsimile at (212) 758-2982. All correspondence should continue to be directed to our below listed address.

Respectfully submitted,



Attorney for Applicants

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